



INFORMATION DISCLOSURE STATEMENT

Applicant : Miles, Mark W.
App. No : 09/875,401
Filed : June 5, 2001
For : DIRECTLY LAMINATED TOUCH
SENSITIVE SCREEN
Examiner : Jennifer T. Nguyen
Art Unit : 2674

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

5/30/2006

(Date)

E. Nelson

Eric M. Nelson, Reg. No. 43,829

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 45 references to be considered by the Examiner. Also enclosed are 15 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

06/05/2006 EAYALEW1 00000036 111410 09875401

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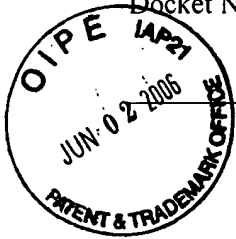
Dated: 5/30/2006

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

By: E. Nelson

Eric M. Nelson
Registration No. 43,829
Attorney of Record
Customer No. 20,995
(619) 235-8550



Please Direct All Correspondence to Customer Number 20995

**TRANSMITTAL LETTER
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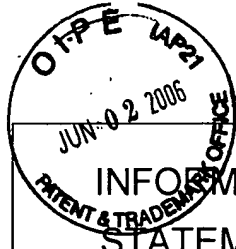
Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement and PTO/SB/08 equivalent listing references for consideration:
 - (X) Listing 45 references.
 - (X) Enclosing 15 references.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

E. M. Nelson

Eric M. Nelson
Registration No. 43,829
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Multiple sheets used when necessary)

SHEET 1 OF 2

Application No.	09/875,401
Filing Date	June 5, 2001
First Named Inventor	Miles, Mark W.
Art Unit	2674
Examiner	Jennifer T. Nguyen
Attorney Docket No.	IRDM.122A

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1	4,392,711	7/12/1983	Moraw et al.	
	2	4,459,182	7/10/1981	Te Velde	
	3	4,857,978	8/15/1989	Goldburt et al.	
	4	4,900,136	2/13/1990	Goldburt et al.	
	5	4,900,395	2/13/1990	Syverson et al.	
	6	4,965,562	10/23/1990	Verhulst	
	7	5,142,414	8/25/1992	Koehler	
	8	5,228,013	7/13/1993	Bik	
	9	5,293,272	3/8/1994	Jannson et al.	
	10	5,324,683	6/28/1994	Fitch et al.	
	11	5,326,430	7/5/1994	Cronin et al.	
	12	5,358,601	10/25/1994	Cathey	
	13	5,474,865	12/12/1995	Vasudev	
	14	5,499,037	3/12/1996	Nakagawa et al.	
	15	5,526,327	6/11/1996	Cordova, Jr.	
	16	5,552,925	9/3/1996	Worley	
	17	5,559,358	9/24/1996	Burns et al.	
	18	5,629,790	5/13/1997	Neukermans et al.	
	19	5,636,185	6/3/1997	Brewer et al.	
	20	5,673,139	9/30/1997	Johnson	
	21	5,683,591	11/4/1997	Offenberg	
	22	5,726,480	3/10/1998	Pister	
	23	5,793,504	8/11/1998	Stoll	
	24	5,808,780	9/15/1998	McDonald	
	25	5,943,158	8/24/1999	Ford et al.	
	26	6,100,872	8/8/2000	Aratani et al.	
	27	6,243,149	6/5/2001	Swanson et al.	
	28	2002/0024711	2/28/2002	Miles	
	29	2002/0054424	5/9/2002	Miles	

Examiner Signature

Date Considered

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

T¹ - Place a check mark in this area when an English language Translation is attached.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Multiple sheets used when necessary)

SHEET 2 OF 2

Application No.	09/875,401
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Examiner	Jennifer T. Nguyen
Attorney Docket No.	IRDM.122A

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	30	2002/0149828	10/17/2002	Miles	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	31	EO 0667548	8/16/1995	AT&T Corp.		
	32	JP 405,275,401	10/22/1993	Ikeda		
	33	ROC PAT PUB NO. 157313	5/1/1991	FSI International, Inc		

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
	34	BASS, "Handbook of Optics, Volume I, Fundamentals, Techniques, and Design, Second Edition," McGraw-Hill, Inc., New York, pp. 2.29-2.36 (1995)	
	35	IBOTSON, et al. "Comparison of XeF ₂ and F-atom reactions with Si and SiO ₂ , Applied Physics Letters." Vol.44, No.12, June 1984. pp.1129-1131.	
	36	Schnakenberg, et al. "THAHW Etchants for Silicon Micromachining." 1991 International Conference on Solid State Sensors and Actuators - Digest of Technical Papers. Pp.815-818.	
	37	Williams, et al. "Etch Rates for Micromachining Processing - Journal of Microelectromechanical Systems. Vol.5 No.4, December 1996, pp.256-269.	
	38	Winters, et al., "The Etching of Silicon with XeF ₂ Vapor." Applied Physics Letters, Vol.34. No.1, Jan.1979, pp.70-73.	
	39	Austrian Search Report from Patent Application No.11/097509, July 14, 2005.	
	40	Austrian Search Report from Patent Application No. 11/097509, July 29, 2005	
	41	Austrian Search Report from Patent Application No. 11/096546, May 19, 2005.	
	42	Austrian Search Report from Patent Application No. 11/140560, August 11, 2005.	
	43	Austrian Search Report from Patent Application No. 11/066724, May 13, 2005.	
	44	Austrian Search Report from Patent Application No. 11/097,818, July 14, 2005.	
	45	Austrian Search Report from Patent Application No. 11/097,820, June 29, 2005.	

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Examiner Signature

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